

**PATENT APPLICATION**

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1751

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Shunichi SEKI et al.

Application No.: 09/701,534

Docket No.: 107291

Filed: November 30, 2000

For: METHOD FOR FORMING A SILICON FILM AND INK COMPOSITION FOR INK  
JET

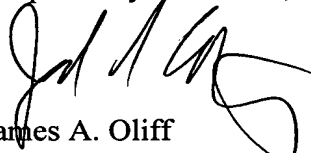
**REQUEST FOR CORRECTION OF PALM RECORDS**

Director of the U.S. Patent and Trademark Office  
Washington, D.C. 20231

Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records.

Respectfully submitted,

  
James A. Oliff  
Registration No. 27,075

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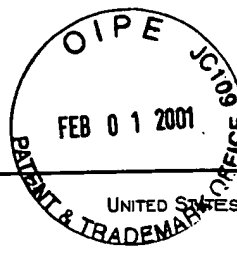
Date: February 1, 2001

OLIFF & BERRIDGE, PLC  
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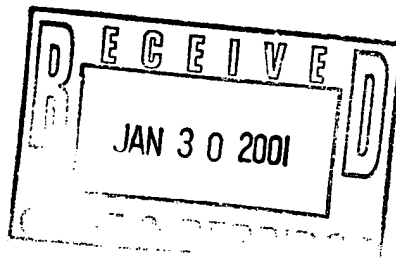
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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/701,534	11/30/2000	1751	976	107291	7	22	4

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## FILING RECEIPT



\*OC000000005711313\*

Date Mailed: 01/26/2001

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the PTO processes the reply to the Notice, the PTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

## Applicant(s)

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## Continuing Data as Claimed by Applicant

THIS APPLICATION IS A 371 OF PCT/JP00/01987 03/29/2000

## Foreign Applications

JAPAN 11-090311 03/30/1999

If Required, Foreign Filing License Granted 01/26/2001

## Title

Method for forming a silicon film and ink composition for ink jet

## Preliminary Class

008

**Date:** 01/26/2001

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